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<b>SERIAL NUMBER</b> 10/517,655	<b>FILING OR 371(c) DATE</b> 12/13/2004 <b>RULE</b>	<b>CLASS</b> 702	<b>GROUP ART UNIT</b> 2863	<b>ATTORNEY DOCKET NO.</b> 122035
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## APPLICANTS

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## \*\* CONTINUING DATA \*\*\*\*\*

This application is a 371 of PCT/JP03/07320 06/10/2003

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

JAPAN 2002173268 06/13/2002

## IF REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 09/25/2006

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	<b>STATE OR COUNTRY</b> JAPAN	<b>SHEETS DRAWING</b> 8	<b>TOTAL CLAIMS</b> 437 109	<b>INDEPENDENT CLAIMS</b> 2
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> Met after Allowance				
Verified and Acknowledged Examiner's Signature: <i>[Signature]</i> Initials: <i>[Initials]</i>				

## ADDRESS

25944

## TITLE

METHOD OF EVALUATING SHAPE OF SEMINCONDUCTOR WAFER AND APPARATUS FOR EVALUATING SHAPE OF SEMINCONDUCTOR WAFER

<b>FILING FEE RECEIVED</b> 6600	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees
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